Infinitesimal Machinery

Based on Feynman's 1983 speech

Feynman's award

Announced in 1959 speech titled 'There's Plenty of Room at the Bottom'

Perhaps this doesn't excite you to do it, and only economics will do so. Then I want to do something; but I can't do it at the present moment, because I haven't prepared the ground. I hereby offer a prize of \$1000 to the first guy who can take the information on the page of a book and put it on an area 1/25 000 smaller in linear scale in such manner that it can be read by an electron microscope.

And I want to offer another prize—if I can figure out how to phrase it so that I don't get into a mess of arguments about definitions—of another \$1000 to the first guy who makes an operating electric motor—a rotating electric motor which can be controlled from the outside and, not counting the lead-in wires, is only 1/64 inch cube.

I do not expect that such prizes will have to wait very long for claimants.1

1/64 inch ~ 390 μ m cube

The McLellan Micromotor





William McLellan (1924-2011), a Caltech graduate, spent just 2½ months laboring on the project, using tools such as toothpick and a watchmaker's lathe. About the size of a speck of sand, it is mounted under a microscope so that the individual parts can be seen.

Motor diameter: 15/1000 inch ~ 375 μm

https://m.facebook.com/quantumphysics.mza/posts/richard-feynman-and-william-mclellanthe-worlds-smallest-motor-in-dec-1959-feynma/3764121993693485/

https://pasadenahistory.org/collections/micromotor/

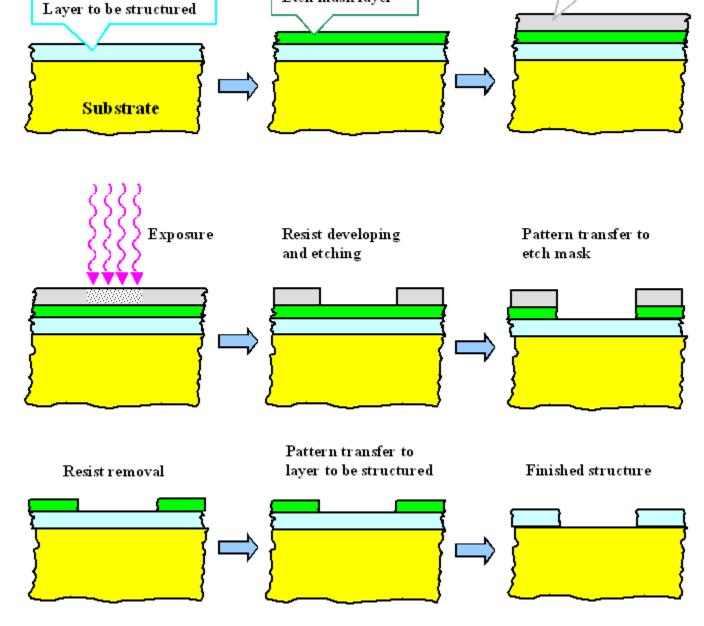
https://www.theguardian.com/science/2004/jun/10/science.nanotechnology
Introduction to Microsystems | Dr. Amruta R Behera

Tom Van Sant's 'eyes' paintings

- https://vimeo.com/52267509
- https://landsat.gsfc.nasa.gov/article/a-big-eye-in-the-mojave-desert/

Micromachining

- Manufacturing at macroscale
- 3 basics steps for translating it to microscale
 - Deposition
 - Patterning
 - Etching

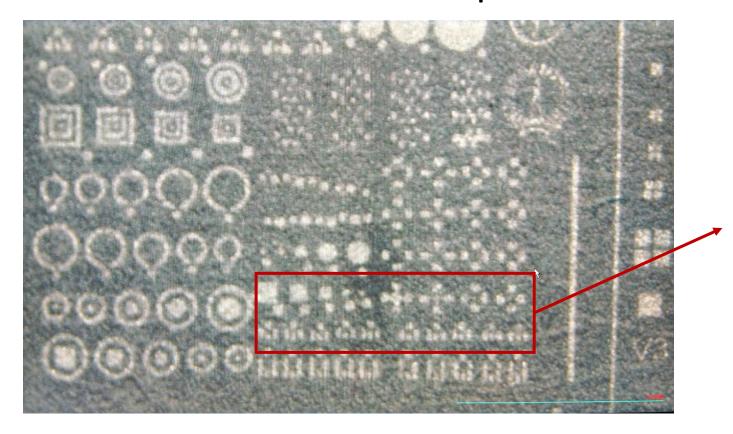


Etch mask layer

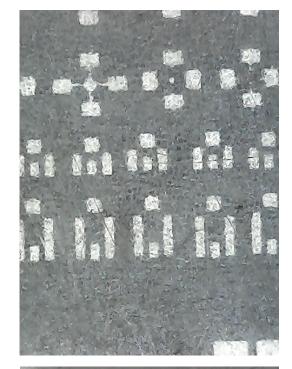
https://www.tf.uni-kiel.de/matwis/amat/elmat_en/kap_6/backbone/r6_6_1.html

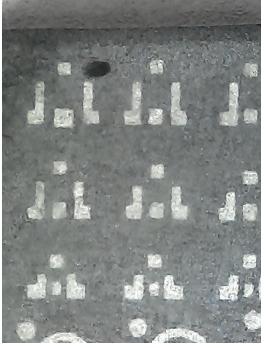
Photo resist

Microfabricated patterns

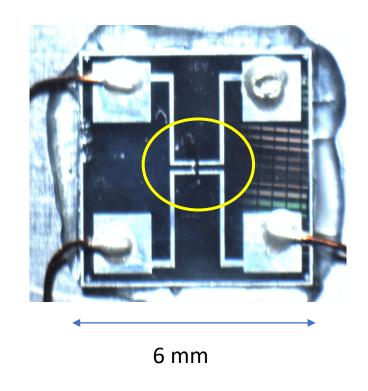


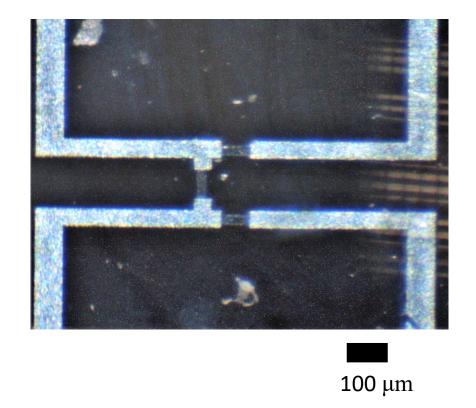
Courtesy: CeNSE, IISc





MEMS strain sensor





Device and image by Shiva Karthik

MEMS Gallery | Sandia Labs

https://www.sandia.gov/mesa/mems-video-image-gallery/

The Scale of Things – Nanometers and More

Things Natural







Human hair ~ 60-120 µm wide

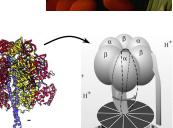


~ 10-20 µm

Ant

~ 5 mm

Red blood cells (~7-8 μm)



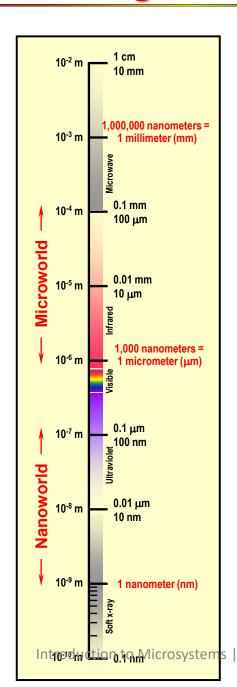
ATP synthase



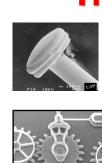
~10 nm diameter

~2-1/2 nm diameter

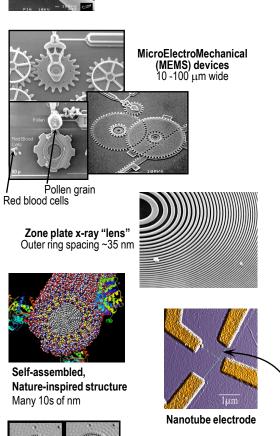
Atoms of silicon spacing 0.078 nm



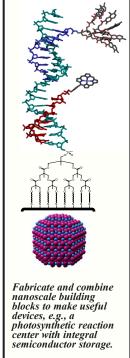
Things Manmade

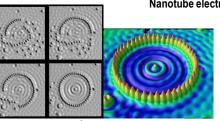


Head of a pin 1-2 mm



The Challenge





Corral diameter 14 nm

DQuantumico ନେଣା ତଥିୟ ନିର୍ମ୍ଦର atoms on copper surface positioned one at a time with an STM tip

Carbon nanotube ~1.3 nm diameter

Carbon buckyball ~1 nm diameter

Methods of making MEMS

Surface micromachining

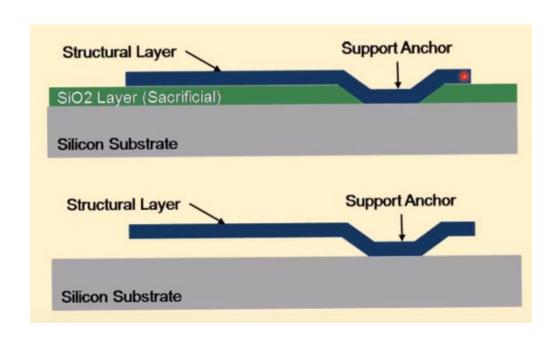
Bulk micromachining

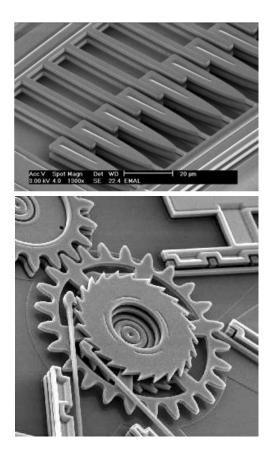
LIGA

Contents adapted from: "MEMS its methods and applications", CHE 384T – Graduate Student Presentation, Ji Yeon Kim, The Department of Chemical Engineering, The University of Texas at Austin

Surface micromachining

- Structural and sacrificial layers
- Low aspect ratio

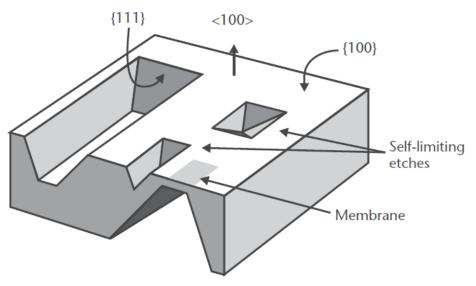


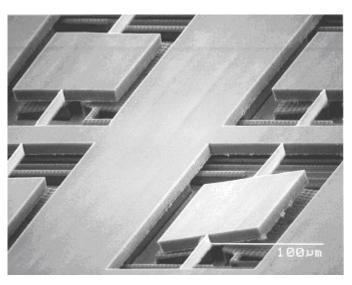


Bulk micromachining

- Subtractive process
- Selective (or anisotropic) etching
 - Wet chemical etching
 - Dry plasma etching
- Higher aspect ratio

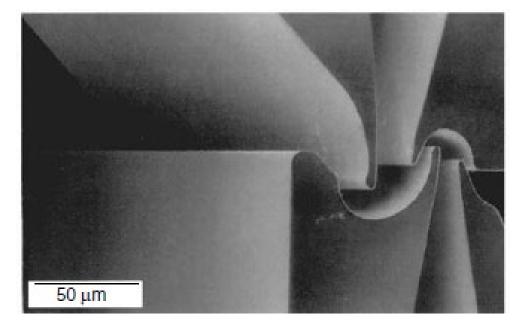
Eg) KOH etch rate: $\{110\} > \{100\} > \{111\}$





LIGA - Lithographie, Galvanoformung, Abformung

- Originally studied for the mass production of micronsized nozzles for uranium isotopes
- Additive process
- Very high aspect ratio (~100)
- Vertical & smooth sidewalls

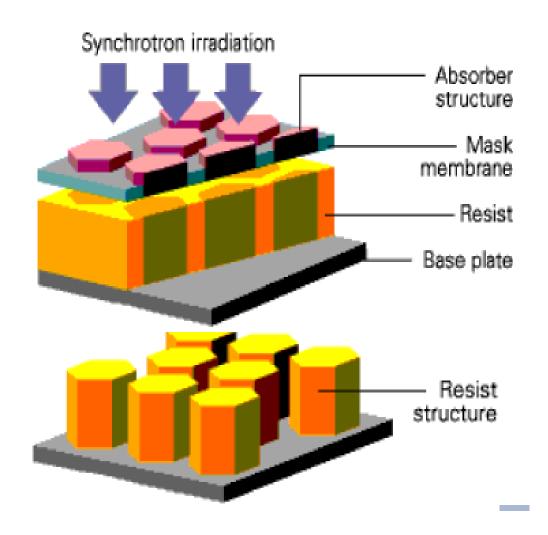




Early 1980s – Karlsruhe nuclear research center in Germany

LIGA – Lithography Step

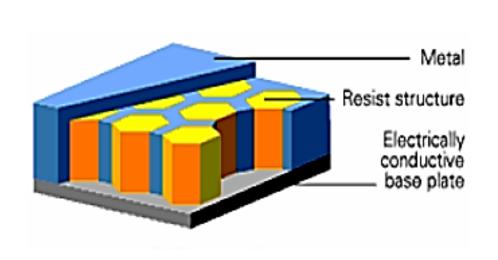
X-ray proximity printing

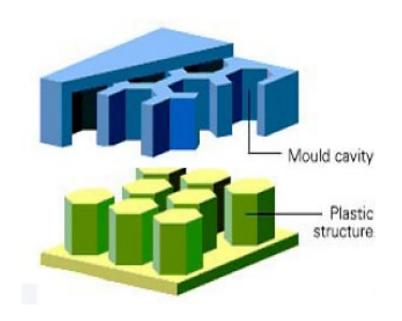


- X-ray mask
 - Thick absorber patterns and thin membrane layer
- Resist
 - PMMA
- Base plate
 - Conducting seed layer (gold/nickel)

LIGA – Electroplating & Molding Step

- Immersing in electrolyte baths (e.g. Ni-sulfamate bath)
- Hot embossing/Injection molding
- Demolding with the help of mold release agents (e.g. 3-6 wt% PAT 665) & design shapes





LIGA – Making a mold insert for plastic molding

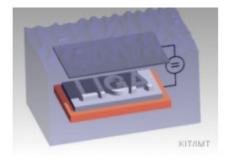


Fig. 29: Nickel electroplating in process

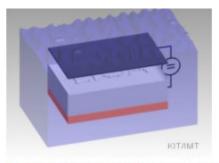


Fig. 30: Nickel electroplating finished

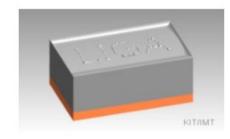


Fig. 31: Nickel mould after electroplating

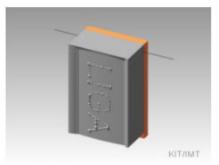
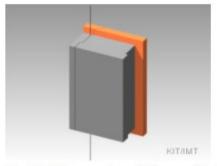


Fig. 32: Wire eroding of the mould, step 1 Fig. 33: Wire eroding of the mould, step 2 Fig. 34: Flood exposure before resist removing



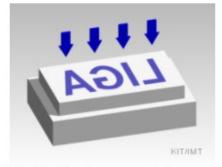




Fig. 35: Finished nickel mould

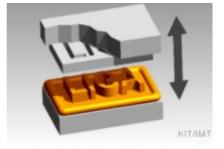


Fig. 36: Moulding for mass replication

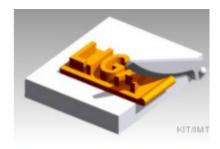
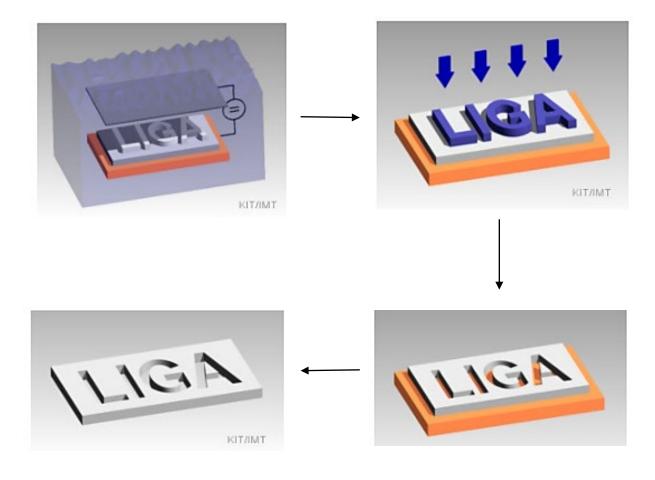


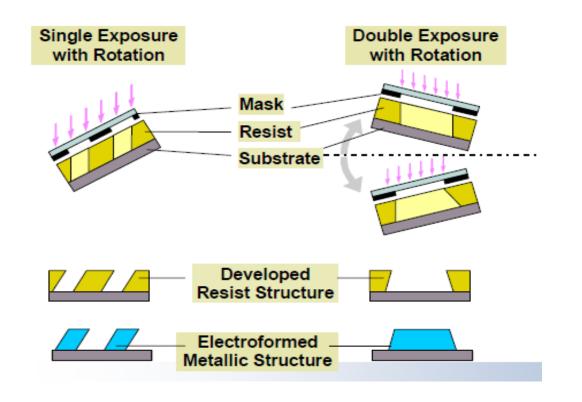
Fig. 37: Final machine finishing

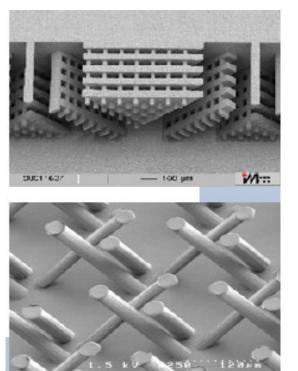
LIGA – Making a microstructure



LIGA – Slanted Microstructures

Complex structures can be fabricated by multiple oblique irradiation





The tools for microfabrication

etching, deposition, lithography



http://nnfc.cense.iisc.ac.in/

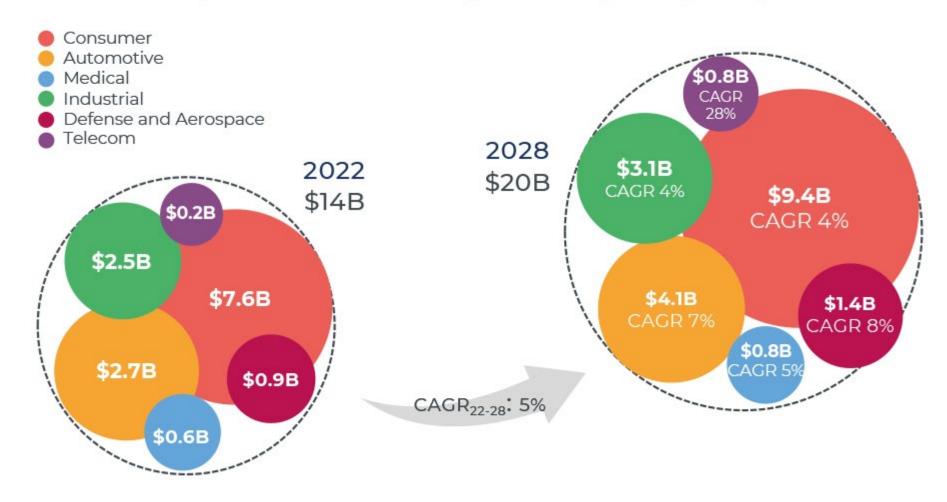
Visit to SCL, Mohali on 14th Feb, 2024

MEMS Market

How relevant is MEMS today?

2022–2028 MEMS market forecast by end market

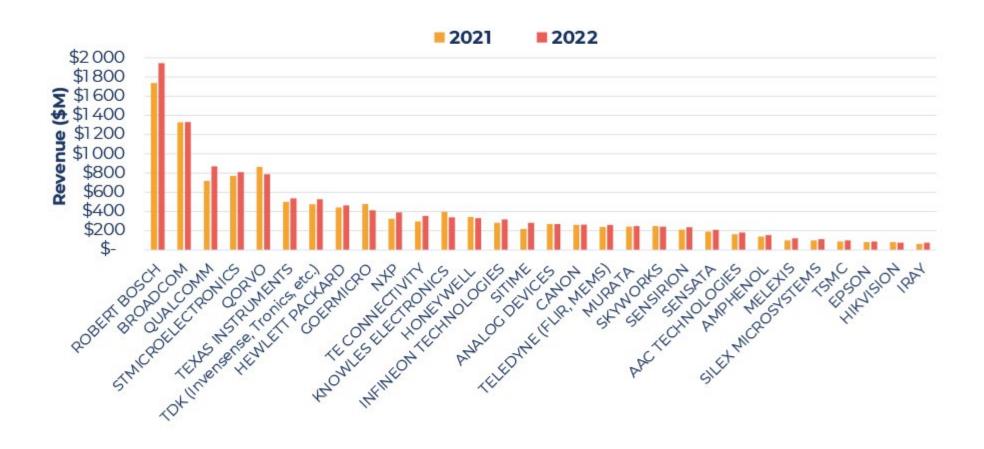
(Source: Status of the MEMS Industry 2023, Yole Intelligence, August, 2023)



https://www.yolegroup.com/product/report/status-of-the-mems-industry-2023/

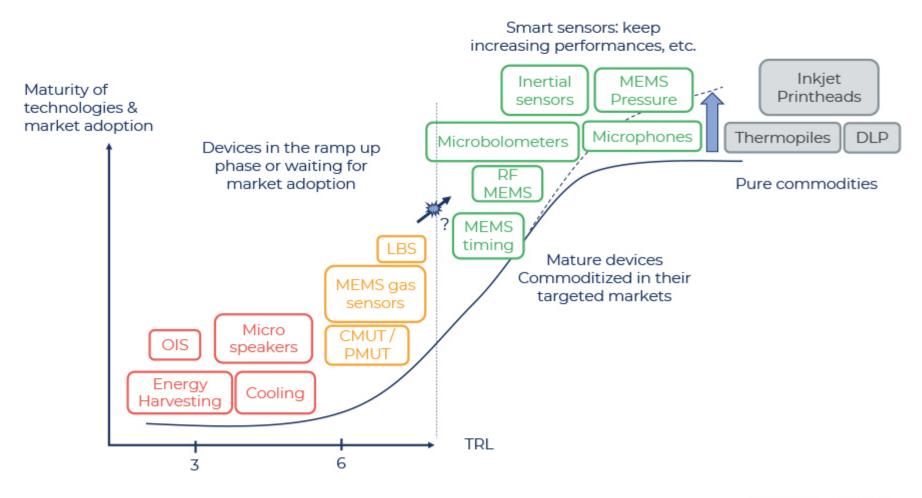
2022 Top MEMS companies ranking

(Source: Status of the MEMS Industry 2023, Yole Intelligence, August, 2023)



MEMS Industry: Who will be next to cross the chasm?

(Source: Status of the MEMS Industry 2023, Yole Intelligence, August, 2023)



Example career options in MEMS/Sensors

- https://www.bosch.de/en/career/
- https://www.indeed.com/viewjob?jk=c242e5cedd10fc3a&tk=1hdt3h n58ioll800&from=serp&vjs=3

Thank You